Docket No.: 2328-023RI **PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: : EXPEDITED PROCEDURE

DUANE C. GATES

Response under 37 CFR 1.116

: Confirmation No. 9066

U.S. Patent Application No. 09/534,814

: Group Art Unit: 3742

Filed: March 22, 2000

: Examiner: MARK H. PASCHALL

For: **EQUIPMENT** 

SEGMENTED COIL FOR GENERATING PLASMA IN PLASMA PROCESSING

## **AMENDMENT**

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

November 22, 2004

Sir:

Appellant respectfully requests that the following amendment as to form be entered to place this application in condition for allowance.